

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re DIVISIONAL application of)
HIDEKAZU MIYAIRI et al.)
Based on Serial No. 10/265,634) Group Art Unit: 2826
Filed: October 8, 2002) Examiner: F. Abraham
For: SEMICONDUCTOR FILM,)
SEMICONDUCTOR DEVICE, AND)
METHOD OF MANUFACTURING THE)
SAME)

INFORMATION DISCLOSURE STATEMENT

Commissioner of Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:


In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, Applicant submits herewith a Form PTO-1449 listing references known to Applicant and requests that these references be made of record in the above identified application.

Copies of U.S. patents and U.S. publications are not enclosed in accordance with the Notice published in the Official Gazette on August 5, 2003 entitled *Information Disclosure Statements May Be Filed Without Copies of U.S. Patents and Published Applications in Patent Applications filed after June 30, 2003*, which waives the requirement under 37 CFR 1.98(a)(2)(i) for submitting a copy of each cited U.S. patent and each U.S. publication.

U.S. Patent No. 5,643,826 is in the family of Japanese Patent Laid-Open No. 07-183540.

The remaining references listed on the attached Form PTO-1449 were cited in parent application Serial No. 10/265,634, and copies of the references can be found in that application.

Respectfully submitted,


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INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>				Complete if Known		
				Application Number	Based on 10/265,634	
				Filing Date	October 8, 2002	
				First Named Inventor	Hidekazu MIYAIRI, et al.	
				Group Art Unit	2826	
Examiner Name	Fetsum Abraham					
Attorney Docket Number	0756-7253					
Sheet	1	of	1			

U.S. PATENT DOCUMENTS						
Examiner Initials [*]	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
		5,643,826		Ohtani et al.	07/01/97	
		5,352,291	B1	Zhang et al.	04/18/00	
		5,352,291		Zhang et al.	10/04/94	
		5,578,520		Zhang et al.	11/26/96	
		6,027,960		Kusumoto et al.	02/22/00	
		6,300,176		Zhang et al.	10/09/01	
		6,348,369		Kusumoto et al.	02/19/02	
		5,861,337		Zhang et al.	01/19/99	
		6,096,581		Zhang et al.	08/01/00	
		6,242,292		Yamazaki et al.	06/05/01	
		5,789,284		Yamazaki et al.	08/04/98	
		5,683,937		Furukawa et al.	11/04/97	
		5,880,487		Furukawa et al.	03/09/99	

FOREIGN PATENT DOCUMENTS							
Examiner Initials [*]	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Office ³	Number ⁴	Kind Code ⁵ (if known)			
		JP	08-078329			03/22/96	Abst.
		JP	2001-60551			03/06/01	Full
		JP	07-183540			07/21/95	Abst.

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials [*]	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
		Katsuyuki SUGA et al., "P-3: The Effect of a Laser Annealing Ambient on the Morphology and TFT Performance of Poly-Si Films," SID 00 DIGEST, pp. 534-537.	

Examiner Signature		Date Considered	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

¹ Unique citation designation number. ² Applicant is to place a check mark here if English language Translation is attached.

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